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Sheet	1	of	1	Attorney Docket Number	Q78854
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## U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> (if known)		
		US 2002/0126266	A1	09-12-2002	Braat et al
		US 6,542,219	B2	04-1-2003	Braat et al.
		US 6,373,552	B1	04-16-2002	Braat et al.
		US 2002/0001088	A1	01-3-2002	Wegmann et al
		US 5,100,237	A	03-31-1992	Wittekoek et al.
		US 6,268,903	B1	07-31-2001	Chiba et al.
		US 5,392,119	A	02-21-1995	McArthur et al.
		US 5,828,455	A	10-27-1998	Smith et al.

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Translation <sup>4</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)		
		DE	101 23 725	A1	11/21/2002	CARL ZEISS
		JP	10-154657	A	6/9/1998	NIKON CORPORATION
		EP	1 022 617	A2	7/26/2000	ASM LITHOGRAPHY B.V.
		EP	0 393 775	A1	10/24/1990	ASM LITHOGRAPHY B.V.
		EP	0 724 199	B1	—	—
		WO	96/07075	A1	03-07-1996	LITEL INSTRUMENTS, INC.
		DE	101 09 929		—	—

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>4</sup>
		C. HOFMANN, ET AL "NANOMETER-ASPHAEREN", FEINWERKTECHNIK & MESSTECHNIK 99 (1991) VOL 10 CARL HANSER VERLAG, MUNICH GERMANY, PAGES 437 -440	

Examiner Signature	<i>John Hes</i>	Date Considered	5-31-05
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